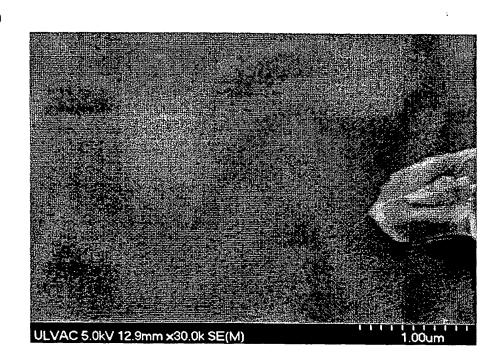
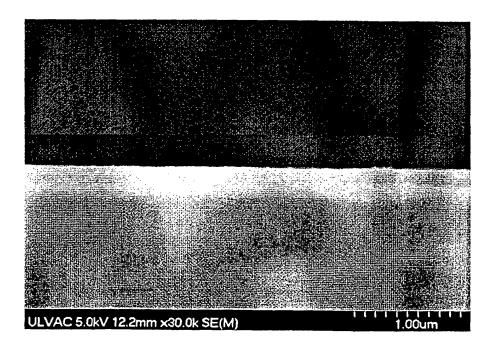
Title: METHOD FOR FORMING POROUS SILICA FILM
Inventor's Name: YAMADA et al.
Application No.: New
Docket No.: 101136-00094

FIG.1

(a)

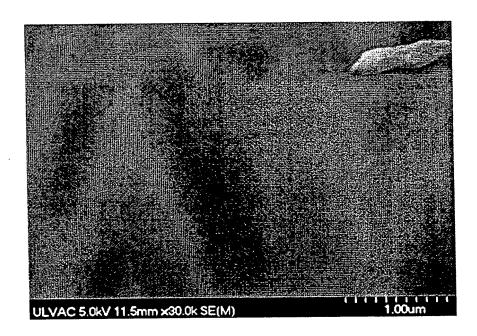


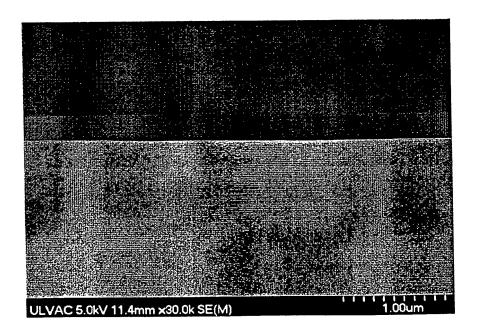


Title: METHOD FOR FORMING POROUS SILICA FILM Inventor's Name: YAMADA et al. Application No.: New Docket No.: 101136-00094

FIG.2

(a)

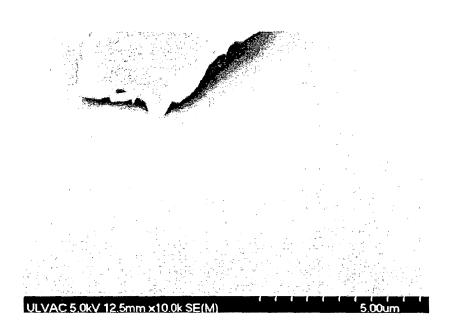


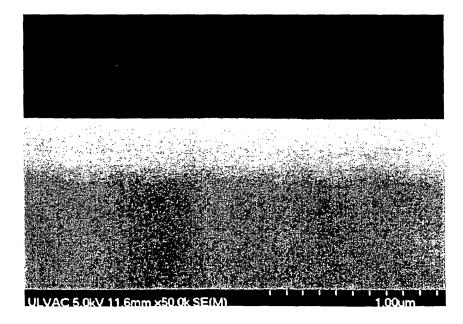


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FIG.3

(a)





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FIG.4

(a)

